

# SEMICONDUCTOR DEVICE

## BACKGROUND OF THE INVENTION

### 5 1. Field of the Invention :

This invention relates to a semiconductor device and more particularly to a semiconductor device in which any fault connection between chip electrodes and a wiring on a wiring substrate is prevented.

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### 2. Description of the Related Art :

There is currently known a semiconductor device called chip side package (hereinafter called the CSP) whose size is reduced almost to the size of a semiconductor chip.

The conventional CSPs are separated into a number of groups according to the kind of an <sup>intermediary</sup> ~~interposer~~ for mounting the semiconductor chip. This <sup>intermediary</sup> ~~interposer~~ is exemplified by a film carrier.

However, if the wiring on the film carrier and the chip electrodes on the semiconductor chip are interconnected by pressing under heat, such joint tends to be separated due to possible stresses so that the joint would become electrically opened.

Fig. 7 of the accompanying drawings of the present specification is a perspective view showing a conventional ordinary-type CSP.

As shown in Fig. 7, a semiconductor chip 1 is disposed on a TAB (Tape Automated Bonding) tape 2, which is a film carrier, has a size substantially equal to that of the TAB tape 2.

Aluminum (Al) chip electrodes (not shown) of the semiconductor chip 1 are electrically connected with bumps 9 via non-illustrated bumps

in through-holes of the TAB tape 2. The whole of the semiconductor chip 1 is sealed by sealing resin 8 such as epoxy resin.

Fig. 8 is a fragmentary, enlarged cross-sectional view taken along line VIII-VIII of Fig. 7.

5 In Fig. 8, the TAB tape 2 is composed of a polyimide tape 2b, which is to be a base, and a wiring 2a of copper foil formed on the polyimide tape 2b, serving as a film carrier (a wiring substrate) on which the semiconductor chip 1 is to be supported.

*A* The wiring 2a is ~~previous~~ <sup>*Prior*</sup> formed on the polyimide tape 2b in a  
10 desired wiring pattern by vapor deposition of copper in the through-holes of the polyimide tape 2b. On the exposed surfaces of each bump 6, another bump 5 as of nickel (Ni) or gold (Au) is formed by plating.

The chip electrodes 4 are electrically connected with a wiring layer 3 in the semiconductor chip 1, the surface of which is covered  
15 with a chip covering film 12 so as to expose the chip electrodes 4.

The thus fabricated film carrier is used in assembling the semiconductor package as follows:

Firstly, with the bumps 5 aligned in confronting relationship with the chip electrodes 4, the wiring 2a are pressed against the bumps  
20 6 under heat or ultrasonic waves using bonding tools. As a result, the individual bump 5 deforms to form gold-aluminum (Au•Al) alloy at the contact surface so that the bump 5 and the corresponding chip electrode 4 are pressed against each other under heat. Then the semiconductor chip 1 and chip covering film 12 are attached to each other by an adhesive  
25 material 11 to complete the semiconductor package. In the meantime, a solder resist 10 is applied over the surface of the exposed wiring 2a for corrosion-proofing.

However, according to this conventional technology, after the bump 5 and the chip electrode 4 are interconnected as pressed under

heat, their joint tends to be separated due to possible stress as of the TAB tape 2, and as a result, the separated joint will be found as a fault connection during inspection after assembling of the semiconductor package.

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# SUMMARY OF THE INVENTION

With the foregoing problems in view, it is an object of this invention to provide a semiconductor device free of any connection fault between chip electrodes and bumps.

According to a first aspect of the invention, the above object is accomplished by a semiconductor device <sup>which</sup> comprises: a wiring substrate having a predetermined pattern of wiring formed on one surface; a semiconductor chip disposed on the other surface of the <sup>wiring</sup> ~~wiring~~ substrate and having two or more chip electrodes in a common wiring layer; the wiring substrate having a number of through-holes; and a number of bumps <sup>Conforming</sup> ~~confronting~~ formed respectively in the through-holes in <sup>confronting</sup> relationship with the chip electrodes and electrically connecting the wiring with the chip electrodes.

According to a second aspect of the invention, the above object is accomplished alternative <sup>ly</sup> by a semiconductor device <sup>which</sup> comprises: a wiring substrate having a predetermined pattern of wiring formed on one surface; a semiconductor chip disposed on the one surface of the wiring substrate and having two or more chip electrodes in a common wiring layer; and a number of bumps disposed on the wiring respectively <sup>Conforming</sup> ~~confronting~~ in relationship with the chip electrodes and electrically connecting the wiring with the chip electrodes.

According to a third aspect of the invention, the above object is accomplished in another alternative way by a semiconductor device

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As a further preferred feature, the chip electrodes comprise at least one kind of terminals selected from ground, power-source and signal terminals of the semiconductor chip.

In the construction of the semiconductor device according to this invention, the device has at least two sets of chip terminals and bumps for a common wiring layer so that if the joint at one position happens to be separated, the remaining joints would be kept from being separated.

5 Accordingly this semiconductor package is free of any connection fault.

#### BRIEF DESCRIPTION OF THE DRAWINGS

The above and other objects, advantages and features of the present invention will be more apparent from the following description taken in conjunction with the accompanying drawings in which :

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Fig. 1 is a fragmentary plan view of a semiconductor device according to a first embodiment of this invention;

Figs. 2(a) and 2(b) are fragmentary cross-sectional views taken along line II-II of Fig. 1, showing the process in which the semiconductor device of Fig. 1 is fabricated;

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Fig. 3 is a fragmentary cross-sectional view showing a semiconductor package to which the construction of Fig. 1 is applied;

Fig. 4 is a fragmentary plan view showing a semiconductor device according to a second embodiment of the invention;

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Fig. 5 is a fragmentary plan view showing a semiconductor device according to a third embodiment of the invention;

Fig. 6 is a fragmentary cross-sectional view showing a semiconductor device according to a fourth embodiment of the invention;

Fig. 7 is a perspective view showing a conventional ordinary-type CSP (chip size package); and

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Fig. 8 is a fragmentary, enlarged cross-sectional view taken along line VIII-VIII of Fig. 7.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

The principles of this invention are particularly useful when applied to a semiconductor device, various preferred embodiments of which will now be described with reference to the accompanying drawings.

Fig. 1 is a fragmentary plan view of a semiconductor device according to a first embodiment of this invention.

In Fig. 1, parts or elements similar to those of Fig. 8 are designated to the same reference numbers. A semiconductor chip 1 is disposed on a TAB (tape automated bonding) tape 2, which is a film carrier (wiring substrate), has a size substantially equal to that of the TAB tape 2. Two chip electrodes 4 as of aluminum (Al) are connected to a common wiring layer 3 of the semiconductor chip 1.

Each of the chip electrodes 4 of the semiconductor chip 1 is electrically connected with a common wiring 2a on the TAB tape 2, and at one end of the wiring 2a, a pad 2c is formed to which a bump is to be attached. The wiring 2a is formed of copper in a desired pattern on the TAB tape 2.

The fabrication process of the semiconductor device of the first embodiment will now be described with reference to Figs. 2(a) and 2(b).

Fig. 2(a) and 2(b) are cross-sectional views taken along line II-II of Fig. 1, showing the process in which the semiconductor device of Fig. 1 is fabricated.

Firstly, in Fig. 2(a), the TAB tape 2 serving as a film carrier is composed of a polyimide tape 2b, which is to be a base, and a wiring 2a of copper foil formed on the polyimide tape 2b. Then, with the bumps 5 aligned with the chip electrodes 4, the wiring 2a is pressed against the bumps 6 with application of heat or ultrasonic waves by two bonding tools 7. Thus the semiconductor chip 1 is mounted on the TAB tape 2.

5           For a stronger joining strength, three or more chip electrodes  
4 may be disposed one in corresponding to each set of the bumps 5 and  
6.

10           In Fig. 3, the wiring 2a is connected at two positions one to each of the chip electrodes 4 via the respective sets of bumps 5, 6. At one end of the wiring 2a, a pad 2c is formed to which a large bump 9 for connection with a package substrate is mounted.

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This invention can applied also to any terminal, such as a power-source terminal (VCC), a ground terminal (GND) and a signal terminal, of the semiconductor chip 1. If it is applied to the ground

terminal, the following results can be obtained.

Namely, in general, a semiconductor chip is equipped with a plurality of power-source terminals and a plurality of ground terminals so that, if connection fault happens to occur at one joint, the other joints remain closed to completely perform its original function. However, if connection fault is found even at one joint during product inspection by the user, he or her might doubt about the technology level and technology level of the manufacturer. Such danger can be avoided by applying this invention to at least power-source and ground terminals. Although, as a demerit, the area occupied by the chip electrodes would increase, possible influence is negligibly small as long as the invention is applied to only power-source terminals and ground terminals. Besides, since sure connection can be achieved, it is valuable to apply the invention to power-source terminals and ground terminals even with some risk of increasing the area the chip electrodes occupy.

In the illustrated embodiments, the bumps 5 are disposed on the rear surface of the semiconductor chip 1. Alternatively, the wiring 2a and the bumps 5 are disposed in confronting relationship with one another as shown in Fig. 6.

According to the semiconductor device of this invention, the wiring on the wiring substrate is connected with two or more chip electrodes connected to a common wiring layer of the semiconductor chip so that, if even a single joint happens to be separated, the other joints remain closed. According<sup>ly</sup> the semiconductor device is free of any connection fault as a whole.

It is thus apparent that the present invention is not limited to the above embodiments but may be changed and modified without departing from the scope and spirit of the invention.



